



Paul Shirley et al.

Serial No.: 10/765,481

Filed: January 27, 2004

**For: METHOD AND APPARATUS
FOR A TWO-STEP RESIST SOFT
BAKE TO PREVENT ILL
OUTGASSING DURING
SEMICONDUCTOR PROCESSING**

[illegible]

Group Art Unit: 2823

Examiner: Toledo, Fernando L.

Atty. Docket: MICS:0117/FLE/FAR
02-1051

**Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450**

I hereby certify that this correspondence is being deposited with the U.S. Postal Service as First Class Mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date below:

June 5, 2006

Date _____

Michael G. Fletcher

In response to the Final Office Action mailed April 3, 2006, please reconsider the above-identified application in view of the following remarks: